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FROM: Glenn M. Kubota DATE: December 4, 2003

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Comments:			
Please see attached.	•		
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PATENT Docket No. 199372001800

Examiner: Jeffrey A. Shapiro

Group Art Unit: 3653

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Akira KOGUCHI

Serial No.:

09/611,635

Filing Date:

July 7, 2000

For:

CONTAINER HANDLING SYSTEM

FOR SUBSTRATE PROCESSING APPARATUS AND METHOD OF HANDLING CONTAINERS

PROPOSED CLAIM AMENDMENTS

Dear Examiner Shapiro:

Here are the amendments I will be proposing during the interview at 1 p.m. on Monday, Dec. 8, 2003. For clarity, I have removed all previously canceled and withdrawn claims and rearranged the order of the claims (but not the numbers) so that independent claims 24 and 25 appear at the beginning, because all claims except claims 28-30 now depend from claims 24 and 25.

With the limitations added by the proposed amendments, we believe that the present invention can be distinguished from Davis, because Davis does not disclose a sensing device coupled to the movable table as in the present invention, and neither Davis nor any of the other cited references disclose a cut-away area shaped and sized to allow the sensing device uninterrupted access to the substrates as the movable table is moved perpendicular to the substrates into a first position under the first stage, as in the present invention.

See you on Monday!

Regards,

Glenn M. Kubota